



35.C14023

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAMAKI KOBAYASHI, ET AL.) : Examiner: Not Yet Assigned
Application No.: 09/440,535) : Group Art Unit: 2879
Filed: November 16, 1999) :
For: SUBSTRATE FOR ELECTRON) :
SOURCE, ELECTRON SOURCE :
AND IMAGE FORMING) :
APPARATUS, AND MANU- :
FACTURING METHOD THEREOF) April 23, 2001

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

RECEIVED
APR 26 2001
336 MAIL ROOM
In compliance with the duty of disclosure under
35 U.S.C. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the documents listed on the enclosed Form
PTO-1449. Copies of the listed documents are also enclosed.

The listed documents were cited in a European
Search Report dated March 1, 2001 (copy enclosed) issued by a
foreign patent office in a counterpart foreign application.

The documents EP 0 865 931, JP 07 331450, and JP 60
015644, listed in the European Search Report, are not listed
on the attached Form PTO-1449, and are not submitted
herewith, since they were previously cited in an Information

Disclosure Statement filed on May 11, 2000 in this application.

For the concise explanation of relevance for the non-English documents, the Examiner is respectfully referred to the English Abstracts attached thereto.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

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